

Notice of References Cited	Application/Control No. 10/593,255		Applicant(s)/Patent Under Reexamination SHIN ET AL.	
	Examiner ROBERT EOM		Art Unit 1797	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Schaevitz et al., A combustion-based MEMS thermoelectric power generator, June 10-14, 1001, The 11th International Conference on Solid-State Sensor and Actuators, Munich, Germany, pg 1-4.
	V	Wijngaards et al., Design and fabrication of on-chip integrated polySiGe and polySi peltier devices, 2000, Elsevier Science S.A., Sensors and Actuators 85, pg 316-323.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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